

FUJIT 020

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of
Katsuhide MANABE et al.

Serial No.: 09/677,781

Filed: October 2, 2000

For: A METHOD FOR MANUFACTURING A GALLIUM NITRIDE GROUP
COMPOUND SEMICONDUCTOR

Commissioner for Patents
Washington, D.C. 20231



Group Art Unit: 2812

Examiner: Mulpuri, S.

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Payton

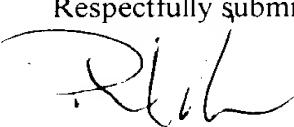
PETITION AND FEE FOR EXTENSION OF TIME
UNDER 37 C.F.R. 1.136(a)

Sir:

Applicant hereby petitions for a two-month extension of time to respond to the Office Action mailed October 15, 2002. A check for the extension fee in the amount of \$410.00 is attached. An Amendment responsive to the outstanding Office Action is being filed simultaneously herewith. A duplicate copy of this sheet is enclosed.

The Commissioner is authorized charge any deficiencies in fees and credit any overpayment of fees to Attorney's Deposit Account No. 50-0481.

Respectfully submitted,


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Reg. No. 46,060

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